

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	: Hideomi Suzawa et al.	Art Unit	: 2812
Serial No.	: 09/852,672	Examiner	: Alexander G. Ghyka
Filed	: May 11, 2001	Confirmation No.:	5083
Title	: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF		

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450


**INFORMATION DISCLOSURE STATEMENT**

Applicants request consideration of the references listed on the attached PTO-1449 form. Under 37 C.F.R. § 1.98 (a)(2)(ii), copies of the listed U.S. patents or U.S. patent application publications are not enclosed and can be provided upon request.

This statement is being filed after filing of a RCE and before the receipt of a next Office Action on the merits. No fees are believed due. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: January 17, 2006

  
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Substitute Form PTO-1449 (Modified)  <b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary)  (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. <b>12732-038001</b>	Application No. <b>09/852,672</b>
	Applicant <b>Hideomi Suzawa et al.</b>		
	Filing Date <b>May 11, 2001</b>	Group Art Unit <b>2812</b>	

**U.S. Patent Documents**

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	2005/0104068 A1	05/19/2005	Yamazaki			12/17/2004
	AB	2005/0110016 A1	05/26/2005	Yamazaki			12/17/2004
	AC	6,130,119	10/10/2000	Jinnai			09/25/1998
	AD	6,534,826 B2	03/18/2003	Yamazaki			04/27/2000
	AE	6,909,114 B1	06/21/2005	Yamazaki			11/04/1999
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

**Foreign Patent Documents or Published Foreign Patent Applications**

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

**Other Documents (include Author, Title, Date, and Place of Publication)**

Examiner Initial	Desig. ID	Document
	AQ	
	AR	
	AS	
	AT	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	